

<b>Search Notes</b>	<b>Application/Control No.</b>	<b>Applicant(s)/Patent Under Reexamination</b>
	10581737	YOSHIMOTO ET AL.
	<b>Examiner</b> HEE-YONG KIM	<b>Art Unit</b> 2482

## SEARCHED

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
375	240.26	8/1/2010	H.K
375	240.26	1/20/2011	H.K

## SEARCH NOTES

<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
Discussed with Andy about search word (Processing/Computation load or cycle)	8/18/2010	H.K and A.R
375/240.26 and ((processing or compuational or computing) (load or cycle or frequency))	8/18	H.K
375/240.26 and ((processing or compuational or computing) (load or cycle or frequency)) and MPEG\$2	8/18	H.K
MPEG\$2 and (operating frequency and bias voltage)	8/18	H.K
MPEG\$2 and (operating frequency and bias voltage) and MOS	8/18	H.K
MPEG\$2 and (operating frequency and bias)	8/18	H.K
MPEG\$2 and (operating frequency and bias) and MOS (add\$3 with margin with estimate) with (fail\$3 or safe\$2)	8/18	H.K
NPL search (MPEG and Operating Frequecny and computation load)	8/20	H.K
Inventor Search at Edan	8/18	H.K

## INTERFERENCE SEARCH

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>